



ELECTRONIC COPY

LG774670166
Report verification at igi.org



February 17, 2026

IGI Report Number **LG774670166**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **OVAL BRILLIANT**

Measurements **8.95 X 6.16 X 3.84 MM**

GRADING RESULTS

Carat Weight **1.34 CARAT**

Color Grade **D**

Clarity Grade **VS 2**

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ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

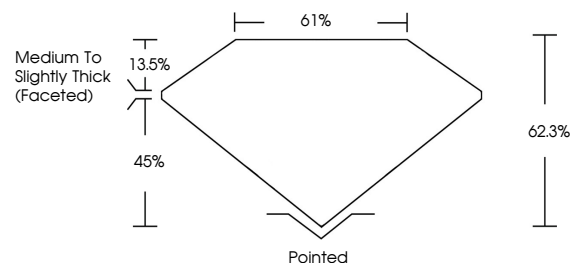
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG774670166**

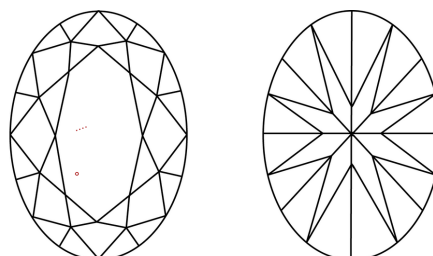
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

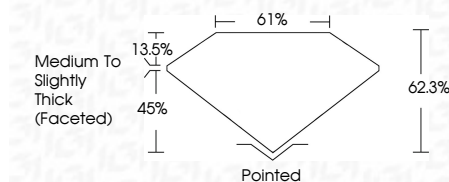
Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

| FL | IF | VS ¹⁻² | VS ¹⁻² | SI ¹⁻² | I ¹⁻³ |
|----------|---------------------|-----------------------------|------------------------|-------------------|------------------|
| Flawless | Internally Flawless | Very Very Slightly Included | Very Slightly Included | Slightly Included | Included |



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IGI



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IGI Report No LG774670166
OVAL BRILLIANT
8.95 X 6.16 X 3.84 MM
1.34 CARAT
Color Grade **D**
Clarity Grade **VS 2**
Table 13.5%
Depth 45%
Width 61%
Height 62.3%
Medium to Slightly Thick (Faceted)
Pointed
Polish **EXCELLENT**
Symmetry **EXCELLENT**
Fluorescence **NONE**
Inscription(s) **IGI LG774670166**

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